



**ELECTRONIC COPY**

**LABORATORY GROWN DIAMOND REPORT**

February 18, 2026  
IGI Report Number **LG775613078**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **8.45 X 5.78 X 3.57 MM**

**GRADING RESULTS**

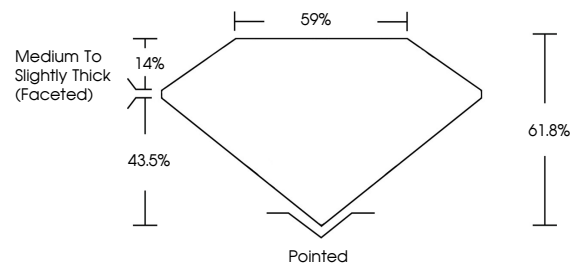
Carat Weight **1.10 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG775613078**

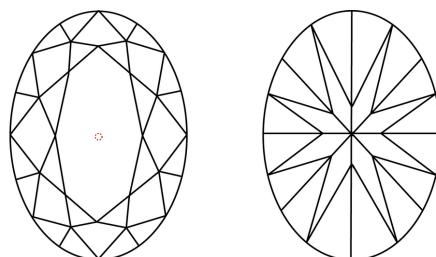
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

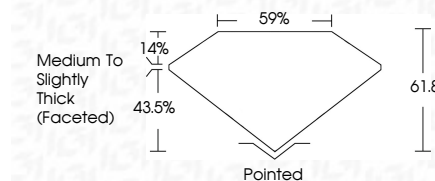
D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



February 18, 2026  
IGI Report Number **LG775613078**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **8.45 X 5.78 X 3.57 MM**  
**GRADING RESULTS**  
Carat Weight **1.10 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG775613078**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



**IGI**



February 18, 2026  
IGI Report No LG775613078  
**OVAL BRILLIANT**  
8.45 X 5.78 X 3.57 MM  
Carat Weight **1.10 CARAT**  
Color Grade **D**  
Clarity Grade **VS 1**  
Table **61.8%**  
Girdle **59%**  
Medium to Slightly Thick (Faceted)  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG775613078**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa